

**IN THE UNITED STATES PATENT AND TRADEMARK  
OFFICE**

In re Applicant:	§ Group Art Unit: 2812
NGUYEN	§
	§
Serial No.: N/A	§
	§ Examiner: Andre C. Stevenson
	§
Filed:	§
	§
For: Removable Lid and	§ Attorney Docket No. SIM026C
Floating Pivot	§

**PRELIMINARY AMENDMENT**

COMMISSIONER OF PATENTS  
AND TRADEMARKS  
Washington, D.C. 20231

Dear Sir:

Before computing fees, please amend the application as follows:

**In the Claims:**

Please cancel claims 1-26.

Please add the following claims:

27. (New) A semiconductor processing system, comprising:
- a chamber adapted to process a wafer, the chamber having an opening to facilitate access to the interior of the chamber;
  - a lid coupled to the chamber opening, the lid having an open position and a closed position;
  - an actuator coupled to the lid to move the lid between the closed position and the open position; and